



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Gu-Sung KIM

Art Unit: 2814

Serial No. 10/073,173

Examiner: Long Pham

Filed: February 13, 2002

Confirmation No. 4677

For: WAFER LEVEL PACKAGE WITH AIR PADS
AND MANUFACTURING METHOD THEREOF

Attorney Docket No. 259/014

PRELIMINARY AMENDMENT

Mail Stop Amendments
Commissioner for Patents
United States Patent and Trademark Office
P.O. Box 1450
Alexandria, Va. 22313-1450

Sir:

INTRODUCTORY COMMENTS

In connection with the Request for Continued Examination filed concurrently herewith and in response to the Office action mailed March 30, 2005, the following amendments and remarks are respectfully submitted in connection with the above-identified application:

AMENDMENTS TO THE CLAIMS are reflected in a listing of claims that begins on page 2 of this paper.

REMARKS/ARGUMENTS begin on page 5 of this paper.